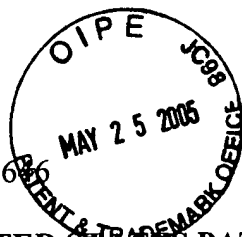


Docket No.: 050432-0686



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Wen YU, et al. : Confirmation Number: 7092
Application No.: 10/782,874 : Group Art Unit: 2823
Filed: February 23, 2004 : Allowed: April 20, 2005
Examiner: William M. Brewster

For: A METHOD OF FORMING A CONTACT IN A SEMICONDUCTOR DEVICE
WITH FORMATION OF SILICIDE PRIOR TO PLASMA TREATMENT

LETTER SUBMITTING FORMAL DRAWINGS

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated April 20, 2005, submitted herewith are Three (3) sheets of Formal Drawings in connection with the above referenced application.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

MS For #26,106 per
John A. Hankins

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Date: May 25, 2005

**Please recognize our Customer No. 20277
as our correspondence address.**